

Electronic Acknowledgement Receipt

EFS ID:	1181963
Application Number:	10721932
Confirmation Number:	8320
Title of Invention:	Method for etching a substrate and a device formed using the method
First Named Inventor:	K.R. Udayakumar
Customer Number:	23494
Filer:	Greg H. Parker
Filer Authorized By:	
Attorney Docket Number:	TI 35507
Receipt Date:	31-AUG-2006
Filing Date:	25-NOV-2003
Time Stamp:	18:43:33
Application Type:	Utility
International Application Number:	

Payment information:

Submitted with Payment	no
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File Listing:

Document Number	Document Description	File Name	File Size(Bytes)	Multi Part	Pages
1	Appeal Brief Filed	Appeal_Brief.pdf	865605	no	20

Warnings:	
Information:	
Total Files Size (in bytes):	865605
<p>This Acknowledgement Receipt evidences receipt on the noted date by the USPTO of the indicated documents, characterized by the applicant, and including page counts, where applicable. It serves as evidence of receipt similar to a Post Card, as described in MPEP 503.</p> <p><u>New Applications Under 35 U.S.C. 111</u> If a new application is being filed and the application includes the necessary components for a filing date (see 37 CFR 1.53(b)-(d) and MPEP 506), a Filing Receipt (37 CFR 1.54) will be issued in due course and the date shown on this Acknowledgement Receipt will establish the filing date of the application.</p> <p><u>National Stage of an International Application under 35 U.S.C. 371</u> If a timely submission to enter the national stage of an international application is compliant with the conditions of 35 U.S.C. 371 and other applicable requirements a Form PCT/DO/EO/903 indicating acceptance of the application as a national stage submission under 35 U.S.C. 371 will be issued in addition to the Filing Receipt, in due course.</p>	